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## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

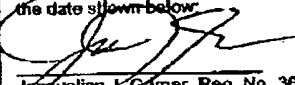
Applicant: Tsuga et al. Art Unit: 1746  
Serial No.: 10/085,725 Examiner: Komakov, M.  
Filing Date: 02/28/2002 Docket No.: TI-31621  
Customer No.: 23494 Conf. No.: 1672  
Title: METHOD AND DEVICE FOR REMOVING PARTICLES ON  
SEMICONDUCTOR WAFERS

OFFICIAL

REQUEST FOR EXTENSION OF TIME

Commissioner of Patents  
PO Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

CERTIFICATION OF FACSIMILE TRANSMISSION	
I hereby certify that the following papers are being transmitted by facsimile to the U.S. Patent and Trademark Office at 703-872-9306 on the date shown below.	
	June 21, 2004 Date
Jacqueline J. Garner, Reg. No. 36,144	

Pursuant to 37 CFR 1.136(a), Applicant(s) respectfully petitions the Commissioner for an extension of the shortened statutory period for response in the above-identified Application.

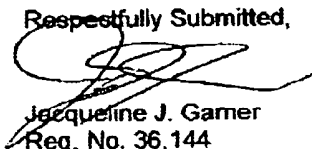
The fee for this extension is indicated below:

- ☐ One Month (\$110)  
☒ Two Months (\$420)  
☐ Three Months (\$950)  
☐ Four Months (\$1,480)

Please charge the fee to deposit account no. 20-0668. Any further necessary extension of time is hereby requested. Charge any and all fees to deposit account no. 20-0668. An original and two copies of this sheet are enclosed.

Texas Instruments Incorporated  
PO Box 655474, M/S 3999  
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Respectfully Submitted,

  
Jacqueline J. Garner  
Reg. No. 36,144

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01 FC:1252 420.00 DA